



#19/Amend B
PATENT RECEIVED
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEREOLITHOGRAPHIC
METHODS FOR FORMING A
PROTECTIVE LAYER ON A
SEMICONDUCTOR DEVICE SUBSTRATE
AND SUBSTRATES INCLUDING
PROTECTIVE LAYERS SO FORMED

Confirmation No.: 1415

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 2269-3923US
(99-0033.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 20, 2003
Date

Signature

Deidra J. Pfeil

Name (Type/Print)

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on May 22, 2003, the three-month shortened statutory period for response to which expires on August 23, 2003.

Amendments to the Claims begin on page 2 of this paper; and

Remarks start at page 10 of this paper.

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